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FILE
APPLICANTS

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Apparatus and method for reducing energy contamination of low energy ion beams

PTO-5040
1/95

DRAWINGS			
Fig. 1	Fig. 2	Fig. 3	Total
(Date) _____ (Assistant Examiner) _____ (Date) _____			NOTICE OF ADJUDICATION _____ _____ _____
(Primary Examiner) _____ (Date) _____			
This terminal _____ months of _____ _____ have been disclaimed.			ISSUE FEE Amount Due _____ Date Paid _____
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